

<b>Notice of References Cited</b>	Application/Control No. 10/538,822		Applicant(s)/Patent Under Reexamination LEE ET AL.	
	Examiner STEPHEN YANCHUK		Art Unit 1795	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,410,728	08-2008	Fujimoto et al.	429/245
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
*	N	JP2000-336491	12-2000	JP	Saito et al.	
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	Q					
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	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Derwent Translation of JP 2000-336491
*	V	English Translation (Machine) of JP 2000-336491
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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